

04-10-01 0280 #2



TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
FIS920000396US1 / I30-0001

In Re Application Of: Mukesh Khare et al.

Serial No.	Filing Date	Batch No.	Examiner	Art Unit
09/809,663	3/15/2001			

Invention:

METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS

Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

9 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c)
on the reverse side of the drawing.

Signature

Sean F. Sullivan
Reg. No. 38,328
Cantor Colburn LLP
55 Griffin Road South
Bloomfield, CT 06002
(860) 286-2929
Customer Service # 23413

Dated: April 3, 2001

I certify that this document and attached formal drawings
are being deposited on 4/3/2001 with the
U.S. Postal Service as first class mail under 37 C.F.R. 1.8
and addressed to the Assistant Commissioner for Patents,
Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Jessica L. Walsh

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